

SEMICON Europa 2026 - Munich, Germany**This schedule is subject to change without notice.**

7:00		8:00		9:00		10:00		11:00		12:00		13:00		14:00		15:00		16:00		17:00		18:00		19:00		20:00	
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Tuesday, November 10, 2026

MEETING LOCATION											
ICM (Room: Staffelsee)		Mercury (HG) Replacement WG 09:00-10:00	Roughness (AFM & Haze) WG 10:00-11:00								

7:00		8:00		9:00		10:00		11:00		12:00		13:00		14:00		15:00		16:00		17:00		18:00		19:00		20:00	
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Wednesday, November 11, 2026

MEETING LOCATION											
ICM (Room: Staffelsee)		Int'l Advanced Surface Inspection (TF) 09:00- 10:00	Int'l Test Methods (TF) 10:00- 11:00	Int'l Polished Wafer (TF) 11:00- 12:00	Silicon Wafer GCS 12:00- 13:00	Int' Advanced Wafer Geometry (TF) 13:00-15:00		Integrated Workflows in Failure Analysis (TF) 16:00- 17:30			

7:00		8:00		9:00		10:00		11:00		12:00		13:00		14:00		15:00		16:00		17:00		18:00		19:00		20:00	
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Thursday, November 12, 2026

MEETING LOCATION											
ICM (Room: Staffelsee)		Silicon Wafer (TC) 09:00-11:00		Compound Semiconductor Materials (TF & TC) 11:15-13:00		Gases and Liquid Chemicals (TC) 14:00-15:00		(By Invitation Only) ERSC 15:30-17:00			
	ICM (Room: 13a)		SEMI Global Standards Summit 9:00 -15:00								

Standards Summit**Compound Semiconductor Materials****Gases and Liquid Chemicals****Physical Interfaces & Carriers****Silicon Wafer****Closed Meeting**